



PATENT

**In the United States Patent and Trademark Office**

Applicants: Craig A. SCHEER et al.

Applicants' Reference: SCATP001

Application No. 10/074,354

Filed: February 11, 2002

Title: PARTICLE DEPOSITION SYSTEM  
WITH ENHANCED SPEED AND  
DIAMETER ACCURACY

Examiner: Tadesse, Y.T.

Group Art Unit: 1734

Date: November 5, 2004

**Confirmation No. 5742**  
(Notice of Allowance Mailed 8/9/04)

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on November 5, 2004.

Signed:

  
Diane Schwanbeck

**Separate Letter to the Official Draftsperson**

Commissioner for Patents  
Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby attach five (5) sheets of formal drawings (Figures 1-5) for the above-identified patent application. In the event the Draftsperson has any questions concerning the formal drawings, he or she is respectfully requested to contact the undersigned. If any fees are due in connection with the filing of these drawings, then please charge such fees to our Deposit Account No. 50-0805 (Order No. SCATP001).

Respectfully submitted,  
MARTINE & PENILLA, LLP



Peter B. Martine  
Reg. No. 32,043

710 Lakeway Drive, Suite 170  
Sunnyvale, California 94085  
(408) 749-6900  
**Customer No. 25920**

Attorney Docket No. SCATP001